



1762

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Group Art Unit: 1762

Hyo-sang JUNG

Examiner: M.L. Padgett

Serial No. 10/068,005

Confirmation No.: 6445

Filed: February 8, 2002

For: VACUUM APPARATUS OF ION  
IMPLANTATION SYSTEM AND  
EVACUATION METHOD

RECEIVED

MAR 01 2004

**PETITION FOR EXTENSION OF TIME**  
**UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 22313-1450

Sir:

It is respectfully requested that an extension of time for the period indicated below be granted in accordance with the provisions of 37 C.F.R. §1.136 to take the action required in the application identified in caption, as reflected by the papers submitted herewith.

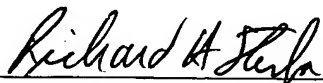
<u>X</u> First Month	\$110 (\$ 55)*
_ Second Month	\$310 (\$155)*
_ Third Month	\$530 (\$265)*
_ Fourth Month	\$530 (\$265)*
_ Fifth Month	\$530 (\$265)*

\*(Small Entity) TOTAL FEE: \$110.00

The Commissioner is hereby authorized to charge the necessary extension fees to our Deposit Account No. 5-01645.

Respectfully submitted,

February 20, 2004  
Date

  
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